

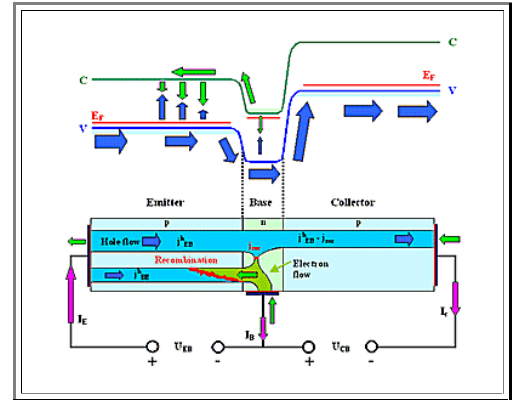
5.5.1 Summary: General Aspects of Silicon Technology

Essentials of the bipolar transistor:

- High emitter doping (N_{Don} for npn transistor here) in comparison to base doping N_{Ac} for large current amplification factor $\gamma = I_C/I_B$.
- $N_{Don}/N_{Ac} \approx \kappa =$ injection ratio.

$$\gamma \approx \frac{N_{Don}}{N_{Ac}} \cdot \left(1 - \frac{d_{base}}{L} \right)$$

- Small base width d_{base} (relative to diffusion length L) for large current amplification.
- Not as easy to make as the band-diagram suggests!

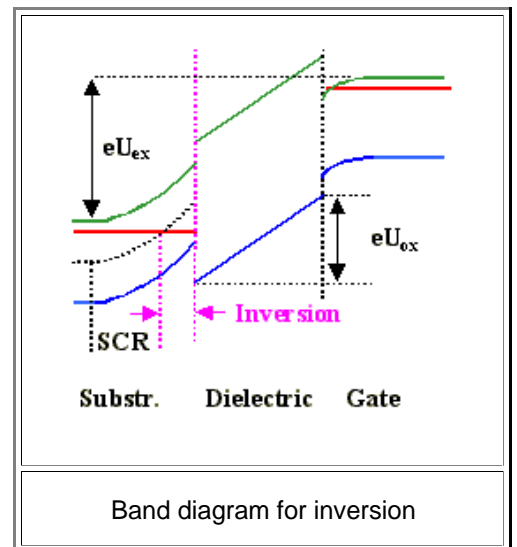
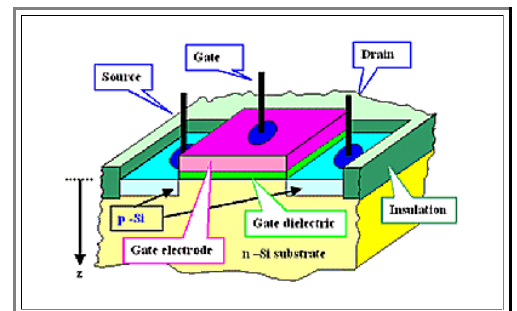


Essentials of the MOS transistor:

- Gate voltage enables Source-Drain current
- Essential process. Inversion of majority carrier type in channel below gate by:
 - Drive intrinsic majority carriers into bulk by gate voltage with same sign as majority carriers.
 - Reduced majority concentration n_{maj} below gate increases minority carrier concentration n_{min} via mass action law

$$n_{maj} \cdot n_{min} = n_i^2$$

- An inversion channel with $n_{min} > n_{maj}$ develops below the gate as soon as threshold voltage U_{Th} is reached.
- Current now can flow because the reversely biased pn-junction between either source or drain and the region below the gate has disappeared.



The decisive material is the gate dielectric (usually SiO_2). Basic requirement is:

- High capacity C_G of the gate electrode - gate dielectric - Si capacitor = high charge Q_G on electrodes = strong band bending = low threshold voltages U_G
- It follows:

- Gate dielectric thickness $d_{Di} \Rightarrow$ High breakdown field strength U_{Bd}
- Large dielectric constant ϵ_r
- No interface states.
- Good adhesion, easy to make / deposit, easy to structure, small leakage currents, ...

$$Q_G = C_G \cdot U_G$$

Example:

$$U = 5 \text{ V}, d_{Di} = 5 \text{ nm} \Rightarrow E = U/d_{Di} = 10^7 \text{ V/cm} !!$$

$$\epsilon_r(\text{SiO}_2) = 3.9$$

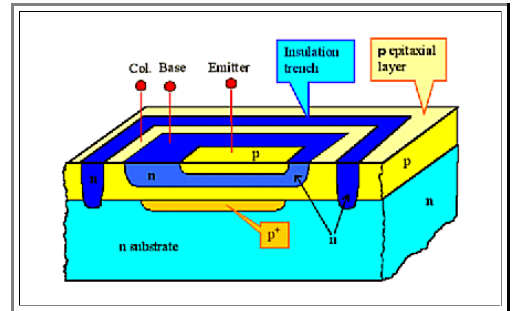
Integration means:

- 1. Produce a large number (up to **1.000.000.000**) of transistors (bipolar or **MOS**) and other electronic elements on a **cm²** of **Si**
- 2. Keep those elements electrically insulated from each other.
- 3. Connect those elements in a meaningful way to produce a system / product.

An integrated bipolar transistor does not resemble the textbook picture at all, but looks far more complicated ⇒.

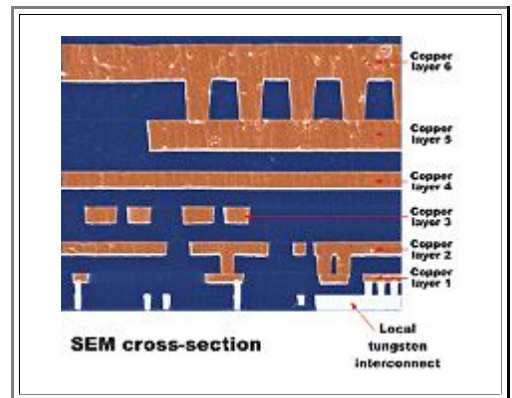
- This is due to the insulation requirements, the process requirements, and the need to interconnect as efficiently as possible.
- The epitaxial layer cuts down on the number of critical diffusions, makes insulation easier, and allows a "buried contact" structure.

It ain't easy!



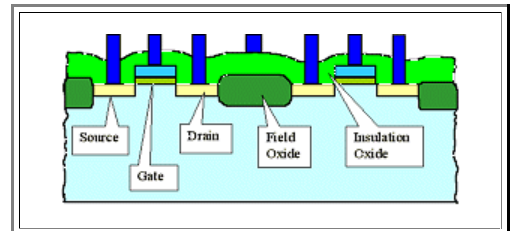
Connecting transistor / elements is complicated; it has to be done on several levels

- Materials used are **Al** ("old"), **Cu** ("new"), **W**, (highly doped) poly-**Si** as well as various silicides.
- Essential properties are the conductivity σ of the conductor, the dielectric constant ϵ_r of the intermetal dielectric, and the resulting time constant $\tau = \sigma \cdot \epsilon_r$ that defines the maximum signal transmission frequency through the conducting line.



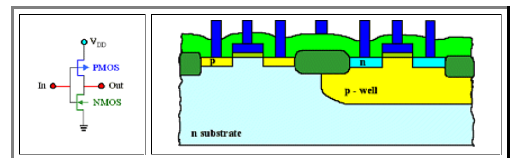
Integrating **MOS** transistors requires special measures for insulation (e.g. a field oxide) and for gate oxide production

- Since a **MOS** transistor contains intrinsically a capacitor (the gate "stack"), the technology can be used to produce capacitors, too.



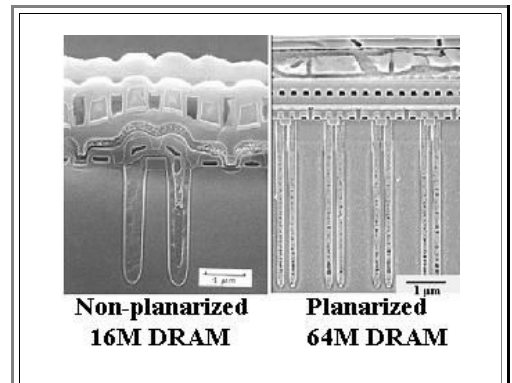
CMOS allows to reduce power consumption dramatically.

- The process, however, is more complex: Wells with different doping type need to be made.



Using the third dimension (depth / height) might become necessary for integrating "large" structures into a small projected are (example: trench capacitor in **DRAMs** ⇒).

- Unwanted "topology", however, makes integration more difficult.
- Planarized technologies are a must since about 1995! ⇒



It ain't neither easy nor cheap!

Property	Number
Feature size	0,2 μm
No. metallization levels	4 - 7
No. components	$> 6 \cdot 10^8$ (Memory)
Complexity	> 500 Process steps
Cost (development and 1 factory)	ca. \$ $6 \cdot 10^9$

Typical wafer size for new factories (2007) : 300 mm diameter, 775 μm thickness, flatness in lower μm region

- Chip size a few cm^2 , much smaller if possible
- Yield Y = most important parameter in chip production = % of chips on a wafer that function (= can be sold).
- $Y = 29\%$ is a good value for starting production

Chip making = running about 20 times (roughly!!) through "materials" - "structuring" loop.

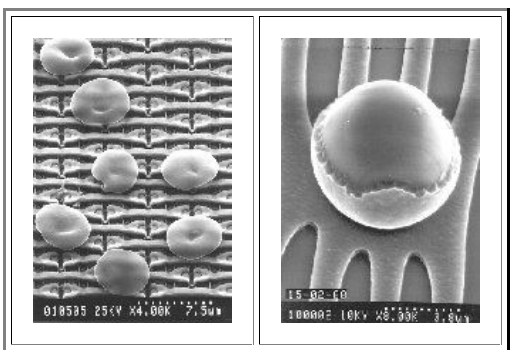
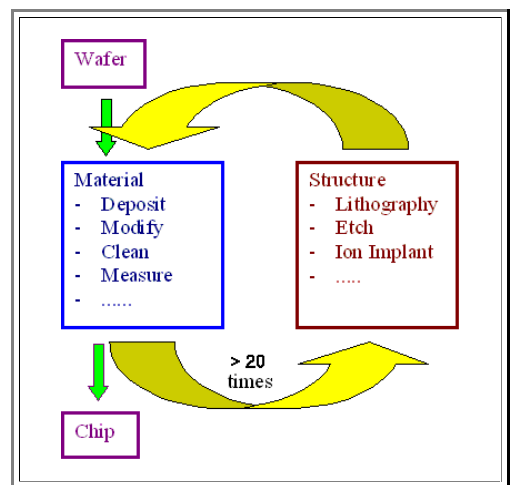
- About 400 - 600 individual processing steps (= in / out of special "machine") before chip is finished on wafer
- More than 30 processing steps for packaging (after separation of chips by cutting)
- Simple estimate: 99.9% perfection for each processing step means $Y < 70\%$.

Dirt in any form - as "particles" on the surface of wafer, or as "contamination" inside the wafer is almost always deadly

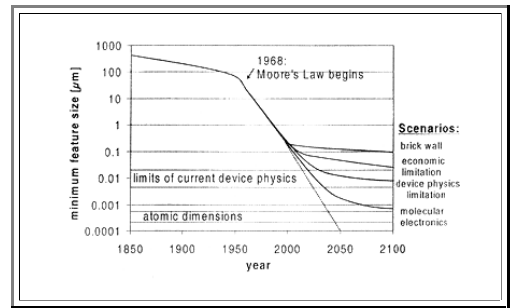
- Particles with sized not much smaller than minimum feature sizes (i.e. $< 10\text{ nm}$ in 2007) will invariably cover structures and lead to local dysfunction of a transistor or whatever.
- Point defects like metal atoms in the **Si** lattice may precipitate and cause local short circuits etc. from the "inside", killing transistors
- One dysfunctional transistor out of 1.000.000.000 or so is enough to kill a chip!

Being extremely clean is absolutely mandatory for high Yields Y !

- Use cleanrooms and hyper-clean materials!
- It won't be cheap!



- ▶ Moore's law predicts exponentially growth of "chip complexity" with a high growth rate - how far will it reach?
 - Problems and costs are growing exponentially with every new generation.
 - It follows: The market must grow exponentially too, if you want to make a profit.
 - It follows: Large amounts of money can be easily made - or lost.
- ▶ Falling behind the competition in your technology and yields means certain death for companies without a monopoly in some product.



Questionnaire

Multiple Choice questions to all of 5